

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Kitaru IWATA, Hiroshi FUKASAKU, Hirohito HAYASHI, Izuru SHIMIZU and Naoya YOKOMACHI

Serial No : TBA

Filed : February 22, 2002

For : ELECTROMAGNETIC ACTUATOR AND METHOD FOR MANUFACTURING ELECTROMAGNETIC ACTUATOR, AND CONTROL VALVE FOR VARIABLE DISPLACEMENT COMPRESSOR USING ELECTROMAGNETIC ACTUATOR

10/081541
02/22/02
U.S. PTO

**INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98**

Box PATENT APPLICATION
Commissioner for Patents
Washington, D.C. 20231

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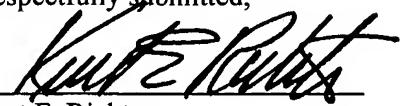
Sir:

It is respectfully requested that the Examiner consider and cite the following references in the above-identified application. Copies of the references are enclosed and the references are identified on Form PTO-1449.

1. U.S. Patent No. 6,062,824, issued May 16, 2000.
2. U.S. Patent No. 6,144,275, issued November 7, 2000.

This Information Disclosure Statement is filed within three months of the filing date of the above-identified application and before the mailing date of a first Office Action on the merits. It is believed that no fee is due.

Respectfully submitted,


Kurt E. Richter
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Dated: February 22, 2002

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FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 5000-4999	SERIAL NO. TBA
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)		APPLICANTS: Kitaru IWATA, et al.	PRO 10/081541 2/22/02 JC979 U.S.
		FILING DATE February 22, 2002	

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	6,062,824	5/16/2000	Kimura, et al.	417	222.2	4/26/1999
	6,144,275	11/7/2000	Hirata, et al.	335	262	7/9/1999

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Papers, Etc.)

EXAMINER	DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.